

**Application Data Sheet****Application Information**

Filing Date:: 4/1/2005 12:00:00AM  
Application Type:: Regular  
Subject Matter:: Utility  
CD\_ROM or CD-R?: None  
Title:: NEAR-FIELD EXPOSURE METHOD AND  
APPARATUS, NEAR-FIELD EXPOSURE MASK,  
AND DEVICE MANUFACTURING METHOD  
Attorney Docket Number:: 00684.103076  
Request for Early Publication:: No  
Request for Non-Publication?: No  
Total Drawing Sheets:: 4  
Small Entity?: No  
Petition included:: No  
Secrecy Order in Parent Appl.?: No

**Applicant Information**

Primary Citizenship Country:: Japan  
Status:: Full Capacity  
Given Name:: Natsuhiko  
Family Name:: MIZUTANI  
City of Residence:: Tokyo  
Country of Residence:: Japan

**Correspondence Information**

Correspondence Customer Number:: 5514

**Representative Information**

Representative Customer Number::	05514
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**Domestic Priority Information**

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National stage of	PCT/JP2004/011648	08/06/2004

**Foreign Priority Information**

Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-290164	08/08/2003	Yes

**Assignee Information**

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